

PATENT NUMBER

2004-0032

PATENT DATE

APPLICATION NO. 09/478812	CONT/PRIOR F	CLASS 438 257	SUBCLASS 172	ART UNIT 283 2815	EXAMINER EUGENE LEE
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PLICANTS Yukiyasu Sugano
Masahiro Fujino
Michio Mano
Akihiko Asano

Process for producing thin film solar cell by device and laser irradiation apparatus

PTO-2040
12/99

ISSUING CLASSIFICATION

[illegible]

<input type="checkbox"/> TERMINAL DISCLAIMER	DRAWINGS		CLAIMS ALLOWED					
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.			
<input type="checkbox"/> The term of this patent subsequent to _____ (date) has been disclaimed.	_____ (Assistant Examiner)		NOTICE OF ALLOWANCE MAILED _____ _____ _____					
<input type="checkbox"/> The term of this patent shall not extend beyond the expiration date of U.S Patent. No. _____ _____ _____	_____ (Primary Examiner)		ISSUE FEE <table border="1"> <tr> <td>Amount Due</td> <td>Date Paid</td> </tr> <tr> <td> </td> <td> </td> </tr> </table>		Amount Due	Date Paid		
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